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HE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64291

Yasuo FUKUDA, et al.

Appln. No.: 09/842,047

Group Art Unit: 3729

Confirmation No.: 6518

Examiner: Tamara D. ALEXANDER

Filed: April 26, 2001

For: METHOD OF FORMING A PROJECTION ELECTRODE (As Amended)

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action dated December 20, 2002, please amend the aboveidentified application as follows:

IN THE TITLE:

Please delete the present title and replace it with the following new title:

METHOD OF FORMING A PROJECTION ELECTRODE[, ITS FORMING METHOD

AND APPARATUS FOR TESTING AN ELECTRONIC COMPONENT]

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